

IN THE U.S. PATENT AND TRADEMARK OFFICE  
I N F O R M A T I O N   S H E E T

jc996 U.S. PRO  
09/813152  
03/21/01

Applicant: NAKABAYASHI, Tetsuya  
UJIMASA, Hitoshi  
ZAITSU, Kazuyuki  
KOKURA, Masafumi

Application No.:

Filed: March 21, 2001

For: SUSCEPTOR AND SURFACE PROCESSING METHOD

Priority Claimed Under 35 U.S.C. 119 and/or 120:

COUNTRY	DATE	NUMBER
JAPAN	03/21/00	2000-078321
JAPAN	01/10/01	2001-002081

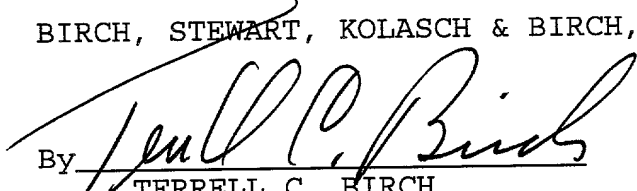
Send Correspondence to: BIRCH, STEWART, KOLASCH & BIRCH, LLP  
P. O. Box 747  
Falls Church, Virginia 22040-0747  
(703) 205-8000

The above information is submitted to advise the USPTO of all relevant facts in connection with the present application. A timely executed Declaration in accordance with 37 CFR 1.64 will follow.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By

  
TERRELL C. BIRCH

Reg. No. 19,382

P. O. Box 747

Falls Church, VA 22040-0747

/smp

(703) 205-8000